

<b>Notice of References Cited</b>		Application/Control No. 10/789,119	Applicant(s)/Patent Under Reexamination KIM ET AL.	
		Examiner Shantell Heiber	Art Unit 2617	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0002471	01-2003	Crawford et al.	370/343
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

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